

FORM PTO-1449 (Rev. 2-32)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 100077	Serial No. TBD
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (Use several sheets if necessary)		Applicant: Heinz Busta	
		Filing Date: October 20, 2003	Group: TBD

## U. S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
SVF	5,602,671	2/11/97	Hornbeck			
	5,694,740	12/9/97	Martin et al.			
	6,004,830	12/21/99	Potter			
	6,025,767	2/15/00	Kellam et al.			
	6,100,477	8/8/00	Randall et al.			
	6,109,105	8/29/00	Kubena et al.			
SVF	6,198,438	3/6/01	Herd et al.			

## FOREIGN PATENT DOCUMENTS

Examiner Initials	Document Number	Date	Country	Class	Sub classes	Translation	
						Yes	No


## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc).

EXAMINER <i>Sto Gull</i>	DATE CONSIDERED <i>1/31/06</i>
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SJF	Wilkerson et al., "Flip-Chip Hermetic Packaging of RF MEMS," MEMS Conference, 2001.
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